



Reg No.: _____

Name: _____

APJ ABDUL KALAM TECHNOLOGICAL UNIVERSITY

B.Tech Degree S3 (S, FE) (FT/WP/S1PT) Examinations May/June 2026 (2019 Scheme)

Course Code: ECT201

Course Name: SOLID STATE DEVICES

Max. Marks: 100

Duration: 3 Hours

PART A

Answer all questions. Each question carries 3 marks

Marks

- | | | |
|----|--|-----|
| 1 | Explain the variation in the position of Fermi level with doping of semiconductor? | (3) |
| 2 | Explain indirect recombination mechanism. | (3) |
| 3 | Explain the variation in mobility with respect to doping? | (3) |
| 4 | Explain Hall effect | (3) |
| 5 | Plot the minority carrier distribution across forward biased PN junction | (3) |
| 6 | Define work function and electron affinity? | (3) |
| 7 | Explain the impact of work function difference in the threshold voltage of a MOS device. | (3) |
| 8 | Differentiate between Enhancement and Depletion mode MOSFETs | (3) |
| 9 | Explain velocity saturation effect in short channel MOSFETs. | (3) |
| 10 | List the advantages of FinFET over MOSFET? | (3) |

PART B

Answer any one full question from each module. Each question carries 14 marks

Module 1

- | | | |
|-------|--|------|
| 11(a) | State and derive law of mass action | (10) |
| (b) | The Fermi level in a Si sample at 300K is located at 0.3eV below the bottom of the conduction band. The effective density of states $N_C = 3.22 \times 10^{19} \text{cm}^{-3}$ and $N_V = 1.83 \times 10^{19} \text{cm}^{-3}$. Determine (i) the electron and hole concentration at 300K (ii) the intrinsic carrier concentration at 300K | (4) |
| 12(a) | Consider Si doped with $2 \times 10^{15} \text{donors/cm}^3$. Assume that $\tau_n = \tau_p = 5 \mu\text{s}$. Calculate the recombination coefficient α_r for the low-level excitation. Find the steady state excess carrier concentration $\Delta n = \Delta p$, if the sample is uniformly exposed to a steady state optical generation rate, | (4) |

$$gop = 10^{19} \text{ EHP/cm}^3\text{-s.}$$

- (b) Explain the temperature dependence of Fermi Dirac distribution in semiconductors (10)

Module 2

- 13(a) Derive continuity equation and Diffusion equation for electrons in a semiconductor. (7)
- (b) A sample of Ge is doped with 10^{14} donors/cm³ and 7×10^{13} acceptors/cm³. If the intrinsic resistivity of the sample at a particular temperature is $60 \Omega\text{cm}$, find the current density due to an applied electric field of 2 V/cm at that temperature. ($\mu_n = 3900 \text{ cm}^2/\text{Vs}$; $\mu_p = 1900 \text{ cm}^2/\text{Vs}$) (7)
- 14(a) Derive the expression for diffusion current density. (10)
- (b) A sample of Si is doped with 10^{17} phosphorus atoms/cm³. Calculate the resistivity, Hall coefficient and Hall voltage of the sample $100 \mu\text{m}$ thick, if $\mu_n = 700 \text{ cm}^2/\text{Vs}$, $I_x = 1 \text{ mA}$ and $B_z = 1 \text{ kG} = 10^{-5} \text{ Wb/cm}^2$. (4)

Module 3

- 15(a) Derive the terminal currents of p-n-p transistor (10)
- (b) Calculate the contact potential V_0 of a Si p-n junction operating at 300 K for $N_a = 10^{15} \text{ cm}^{-3}$ and $N_d = 10^{18} \text{ cm}^{-3}$. Also determine the maximum electric field E_0 at the junction. (4)
- 16(a) In an ideal PN junction at $T = 300 \text{ K}$, find the magnitude of reverse bias voltage required to reach 75% of its reverse saturation current? [$k = 1.38 \times 10^{-23} \text{ JK}^{-1}$, $h = 6.625 \times 10^{-34} \text{ Js}$ and $q = 1.6 \times 10^{-19}$] (7)
- (b) With the aid of energy band diagram, explain how a metal N type Schottky act as a rectifying contact (7)

Module 4

- 17(a) Explain accumulation, depletion and inversion modes in MOS capacitor, with the aid of energy band diagram. (8)
- (b) For a MOSFET with $V_T = 1 \text{ V}$ and $W = 50 \mu\text{m}$, $L = 2 \mu\text{m}$, calculate the drain current at (i) $V_G = 5 \text{ V}$, $V_D = 0.1 \text{ V}$ and (ii) $V_G = 3 \text{ V}$, $V_D = 5 \text{ V}$. Assume an electron channel mobility $\mu_n = 200 \text{ cm}^2/\text{V-s}$ and the substrate is connected to the source. (6)
- 18(a) Derive the expression for drain current in the linear region and saturation region of a MOSFET. (7)

- (b) Find the maximum depletion width, minimum capacitance C_i , and threshold voltage for an ideal MOS capacitor with a 10-nm gate oxide (SiO_2) on p-type Si with $N_a = 10^{16} \text{ cm}^{-3}$. [dielectric constant of Si=11.8, dielectric constant of oxide=3.9] (7)

Module 5

- 19(a) Distinguish between constant voltage scaling and constant field scaling (7)
- (b) Explain the structure and operation of FinFET (7)
- 20(a) Explain subthreshold conduction in a MOSFET. Explain slope factor and its significance (7)
- (b) Explain drain induced barrier lowering and hot carrier effect in a short channel MOSFET (6)
